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MAY 12 2006

Docket No.: 2336-256

PATENT

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of

Ju Hyun KIM et al.

U.S. Patent Application No. 10/810,634

Filed: March 29, 2004

Confirmation No.: 9586

Group Art Unit: 2823

Examiner: FERNANDO L TOLEDO

For: METHOD FOR SEPARATING SAPPHIRE WAFER INTO CHIPS USING DRY-ETCHING

Dear Sir:

Transmitted herewith is an Amendment in the above identified application.

- ☐ No additional fee is required.
- ☐ Small entity status of this application has been established.
- ☐ Also attached:

The fee has been calculated as shown below:

	NO. OF CLAIMS	HIGHEST PREVIOUSLY PAID FOR	EXTRA CLAIMS	RATE	FEE
Total Claims	20	20	0	x \$ 50 =	\$ 0.00
Independent Claims	4	3	1	x \$200 =	\$ 200.00
If multiple claims newly presented, add \$360.00					
Fee for extension of time					
<b>TOTAL FEE DUE</b>					<b>\$ 200.00</b>

- ☒ A credit card authorization form in the amount of \$ 200.00 is attached
- ☒ The Commissioner is hereby authorized to charge payment of any deficiency in fees associated with this communication or credit any overpayment, to Deposit Account No. 07-1337, including any filing fees under 37 CFR 1.16 for presentation of extra claims and any patent application processing fees under 37 CFR 1.17.

Respectfully submitted,

LOWE HAUPTMAN &amp; BERNER, LLP

Benjamin J. Hauptman  
 Registration No.: 29,310

USPTO Customer No. 22429  
 1700 Diagonal Road, Suite 300  
 Alexandria, Virginia 22314  
 (703) 684-1111 BJH/KL/ayw  
 (703) 518-5499 Facsimile  
 Date: May 12, 2006

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Docket No.: 2336-256

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of :  
Ju Hyun KIM *et al.* : Confirmation No. 9586  
U.S. Patent Application No. 10/810,634 : Group Art Unit: 2812  
Filed: March 29, 2004 : Examiner: Fernando L Toledo  
For: METHOD FOR SEPARATING SAPPHIRE WAFER INTO CHIPS USING DRY-  
ETCHING

AMENDMENT

COMMISSIONER FOR PATENTS  
P.O. Box 1450  
Alexandria VA 22313-1450

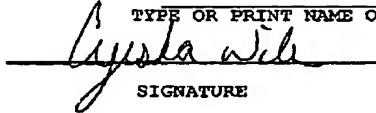
Sir:

The following amendments and remarks are submitted in response to the Official Action dated February 13, 2006.

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